

UNITED STATES PATENT AND TRADEMARK OFFICE  
CERTIFICATE OF CORRECTION

PATENT NO. : 6,936,831 B2

DATED : August 30, 2005

INVENTOR(S) : Fujiwara et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 8.

Lines 33-34, "apparatus a reticle stage," should be --apparatus comprises a reticle stage,--.

Column 10.

Line 18, "portions, 110 as described" should be --portion, as described--.

Column 11.

Line 61, "to as to" should be --so as to--.

Column 16.

Line 45, " $2(D_{CW}D_{SW})=N_S$ " should be -- $2(D_{CW}/D_{SW})=N_S$ --.

Column 17.

Line 48, "stripe 594." should be --stripe 59-4.--.

Column 19.

Line 33, "to 494," should be --to 49-4,--.

Column 20.

Line 66, "and 44-4," should be --and 42-4,--.

Column 22.

Line 13, "stripe 491 of" should be --stripe 49-1 of--.

Column 23.

Line 8, "and 494." should be --and 49-4.--.

Column 24.

Line 3, "494 defining" should be --, 49-4 defining--.

Line 22, "reticles 101," should be --reticles 10-1,--.

Line 59, "die 504." should be --die 50-4.--.

Column 25.

Line 14, "In step S2, step S2" should be --In step S2--.

Line 21, "S4-S13" should be --Steps S4-S13--.

Lines 29-30, "substrate. (typically by vapor deposition)." should be --substrate (typically by vapor deposition).--.

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PATENT NO. 6,936,831

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